

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Group Art Unit: 1753

Basol

Examiner: Not yet assigned

Docket: NT-319-US

Serial No.: 10/772,687

Filed: February 5, 2004

Title: PROCESS AND SYSTEM FOR PROVIDING ELECTROCHEMICAL

PROCESSING SOLUTION WITH REDUCED

OXYGEN AND GAS CONTENT

INFORMATION DISCLOSURE STATEMENT

US PATENT DOCUMENTS

Examiner	Cite	Document Number	Publication Date	Name of Patentee or	
Initials	No.			Applicant	
/EW/	AA	6,113,769	Sep., 2000	Uzoh et al.	In Serial No. 10/425,782

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	

OTHER DOCUMENTS

Examiner Initials	Cite No.			Trans- lation
/EW/	AB	Victoria Shannon et al., "Copper Interconnects for High- Volume Manufacturing", Semiconductor International, May 2001	In Serial No. 10/425,782	

Examiner	/Edna Wona/	Date	404004000
Signature	/Edna Wong/	Considered	10/02/2007

Application No. 10/772,687 INFORMATION DISCLOSURE Filing Date February 5, 2004 **First Named Inventor** Basol STATEMENT BY APPLICANT Art Unit 1753 (Multiple sheets used when necessary) Examiner Edna Wong SHEET 1 OF 1 Attorney Docket No. ASMNUT.023CP1

				U.S. PATENT	DOCUMENTS	
	niner ials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
/E\	W/	1	4,081,347	03-28-1978	Becker	
		2	5,383,483	01-1995	Shibano	
		3	5,695,545	12-1997	Cho et al.	
		4	5,762,684	06-1998	Hayashi et al.	
		5	5,788,742	08-1998	Sugimoto et al.	
		6	6,113,769	09-2000	Uzoh et al.	
		7	6,146,517	11-2000	Hoinkis	
		8	6,171,367 B1	01-2001	Peng et al.	
		9	6,328,785 B1	12-2001	Hayashi	
		10	6,328,871 B1	12-11-2001	Ding et al.	
·		11	2001/052465 A1	12-20-2001	Dordi et al.	
		12	2004/0026255 A1	02-2004	Kovarsky et al.	
V	/	13	2004/0060436 A1	04-2004	Parekh et al.	

				FOREIGN PATI	ENT DOCUMENTS		······································
Exan Initi		Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
/EV	V/	14	DE 24 15 573 A	10-02-1975	Köhl		
		15	FR 2 416 958 A	09-07-1979	Bunker Ramo Corporation		
		16	EP 0 901 153 A2	03-10-1999	Kuriyama et al.		
		17	JP 61 012877 A	01-21-1986	Kobayashi		Abstract
		18	JP 2001-196728 A	07-19-2001	Tanaka		Abstract
		19	WO 00/75402 A1	12-14-2000	Stockbower		

NON PATENT LITERATURE DOCUMENTS				
T ¹				

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Examiner Signature	/Edna Wong/	Date Considered	10/02/2007
*Examiner: Initial if refere	ence considered, whether or not citate on side of this form	tion is in conformance with MPEP 609. with next communication to applicant.	Draw line through citation if not

T¹ - Place a check mark in this area when an English language Translation is attached.

NORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No.	10/772,687
Filing Date	February 5, 2004
First Named Inventor	Bulent M. Basol
Art Unit	1753
Examiner	Edna Wong
Attorney Docket No.	ASMNUT.023CP1

(Multiple sheets used when necessary)
SHEET 1 OF 1

			U.S. PATENT	U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear						
/EW/	1	3,276,983 A	10-1966	Dolan et al.							
	2	3,616,599	11-02-1971	Burnham							
	3	6,110,345 A	08-2000	lacoponi							
	4	6,241,585 B1	06-2001	White							
	5	6,254,760 B1	07-2001	Shen et al.							
V	6	6,267,853 B1	07-2001	Dordi et al.							
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FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T¹
	14			•		
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	18			,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,,		
	19					-

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹		

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Examiner Signature	/Edna Wong/	Date Considered	10/02/2007
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			